

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q91857

Hisaharu NISHIO, et al

Appln. No.: National Stage of PCT/JP2004/009971

Confirmation No.: Unknown

Group Art Unit: Unknown

Filed: January 12, 2006

Examiner: Unknown

For: GAS SENSOR AND METHOD OF MANUFACTURING THE GAS SENSOR

**PRELIMINARY AMENDMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

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